



PATENT APPLICATION *RCE\$ IFW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mutsumi KIMURA et al.

Group Art Unit: 1762

Application No.: 09/077,029

Examiner: J. LIN

Filed: May 18, 1998

Docket No.: JAO 40499

For: MATRIX TYPE DISPLAY DEVICE AND
MANUFACTURING METHOD THEREOF

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 193833 in the amount of ☒ \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Ariana E. Guss
Registration No. 58,997

JAO:AEG/jnm

Date: June 14, 2007

OLIFF & BERRIDGE, PLC
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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

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